

Bo Song

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The third column is the impact factor (IF) of the journal, and the fourth column is the number of citations of the article.

29
papers

1,349
citations

15
h-index

34
g-index

34
ext. papers

1,555
ext. citations

3.7
avg, IF

3.75
L-index

#	Paper	IF	Citations
29	InAlN/AlN/GaN HEMTs With Regrown Ohmic Contacts and f_{T} of 370 GHz. <i>IEEE Electron Device Letters</i> , 2012 , 33, 988-990	4.4	252
28	Esaki Diodes in van der Waals Heterojunctions with Broken-Gap Energy Band Alignment. <i>Nano Letters</i> , 2015 , 15, 5791-8	11.5	237
27	. <i>IEEE Electron Device Letters</i> , 2015 , 36, 375-377	4.4	126
26	1.7-kV and 0.55- $\text{m}\Omega \cdot \text{cm}^2$ GaN p-n Diodes on Bulk GaN Substrates With Avalanche Capability. <i>IEEE Electron Device Letters</i> , 2016 , 37, 161-164	4.4	125
25	Near unity ideality factor and Shockley-Read-Hall lifetime in GaN-on-GaN p-n diodes with avalanche breakdown. <i>Applied Physics Letters</i> , 2015 , 107, 243501	3.4	117
24	Gate-recessed integrated E/D GaN HEMT technology with $f_T/f_{max} > 300$ GHz. <i>IEEE Electron Device Letters</i> , 2013 , 34, 741-743	4.4	70
23	Ultrascaled InAlN/GaN High Electron Mobility Transistors with Cutoff Frequency of 400 GHz. <i>Japanese Journal of Applied Physics</i> , 2013 , 52, 08JN14	1.4	55
22	Polarization-Induced GaN-on-Insulator E/D Mode p-Channel Heterostructure FETs. <i>IEEE Electron Device Letters</i> , 2013 , 34, 852-854	4.4	49
21	High breakdown single-crystal GaN p-n diodes by molecular beam epitaxy. <i>Applied Physics Letters</i> , 2015 , 107, 232101	3.4	44
20	Quaternary Barrier InAlGaN HEMTs With f_T/f_{max} of 230/300 GHz. <i>IEEE Electron Device Letters</i> , 2013 , 34, 378-380	4.4	42
19	Two-dimensional electron gases in strained quantum wells for AlN/GaN/AlN double heterostructure field-effect transistors on AlN. <i>Applied Physics Letters</i> , 2014 , 104, 193506	3.4	35
18	High Holding Voltage SCR-LDMOS Stacking Structure With Ring-Resistance-Triggered Technique. <i>IEEE Electron Device Letters</i> , 2013 , 34, 1178-1180	4.4	35
17	Strained GaN quantum-well FETs on single crystal bulk AlN substrates. <i>Applied Physics Letters</i> , 2017 , 110, 063501	3.4	34
16	Ultralow-Leakage AlGaIn/GaN High Electron Mobility Transistors on Si With Non-Alloyed Regrown Ohmic Contacts. <i>IEEE Electron Device Letters</i> , 2016 , 37, 16-19	4.4	26
15	. <i>IEEE Transactions on Electron Devices</i> , 2014 , 61, 747-754	2.9	23
14	Impact of CF ₄ plasma treatment on threshold voltage and mobility in Al ₂ O ₃ /InAlN/GaN MOSHEMTs. <i>Applied Physics Express</i> , 2014 , 7, 031002	2.4	15
13	Steep Sub-Boltzmann Switching in AlGaIn/GaN Phase-FETs With ALD VO ₂ . <i>IEEE Transactions on Electron Devices</i> , 2018 , 65, 945-949	2.9	11

12	Dual optical marker Raman characterization of strained GaN-channels on AlN using AlN/GaN/AlN quantum wells and ¹⁵ N isotopes. <i>Applied Physics Letters</i> , 2015 , 106, 041906	3-4	10
11	Electron mobility in polarization-doped Al _{0.2} GaN with a low concentration near 10 ¹⁷ cm ⁻³ . <i>Applied Physics Letters</i> , 2017 , 110, 182102	3-4	8
10	AlGa _x GaN HEMTs on Si by MBE with regrown contacts and f _T = 153 GHz. <i>Physica Status Solidi C: Current Topics in Solid State Physics</i> , 2014 , 11, 887-889		8
9	Unique opportunity to harness polarization in GaN to override the conventional power electronics figure-of-merits 2015 ,		5
8	Monolithically integrated E/D-mode InAlN HEMTs with f _T /f _{max} > 200/220 GHz 2012 ,		5
7	Compact MOS-triggered SCR with faster turn-on speed for ESD protection. <i>Microelectronics Reliability</i> , 2010 , 50, 1393-1397	1-2	5
6	A Novel Capacitance-Coupling-Triggered SCR for Low-Voltage ESD Protection Applications. <i>IEEE Electron Device Letters</i> , 2010 , 31, 1089-1091	4-4	4
5	High-voltage polarization-induced vertical heterostructure p-n junction diodes on bulk GaN substrates 2015 ,		3
4	GaN lateral PolarSJs: Polarization-doped super junctions 2014 ,		2
3	Trigger voltage walk-in effect of ESD protection device in HVCMOS 2010 ,		2
2	Comparing buffer leakage in PolarMOSH on SiC and free-standing GaN substrates 2016 ,		1
1	Distributed polarization-doped GaN p ⁺ diodes with near-unity ideality factor and avalanche breakdown voltage of 1.25 kV. <i>Applied Physics Letters</i> , 2022 , 120, 122111	3-4	0